Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/750,264	GUVEN ET AL.	
Examiner	Art Unit	
Dmitry Levitan	2616	

SEARCHED					
Class	Subclass	Date	Examiner		
370	242				
	244				
	252		/		
	351-	p 2/28	06		
	-356		DL		
	401				
	401				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
IEEE, EAST	2/28/00	50/		
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